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APPLICANTS Masayuki Furuhashi, Kawasaki, JAPAN; Toshifumi Mori, Kawasaki, JAPAN; Young Suk Kim, Kawasaki, JAPAN; Takayuki Ohba, Kawasaki, JAPAN; Ryou Nakamura, Kawasaki, JAPAN;				
** CONTINUING DATA ***** None & W.S.				
** FOREIGN APPLICATIONS ***** S.W.S. JAPAN 2002-317456 10/31/2002				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/06/2004				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <i>S.W.S.</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 33	TOTAL CLAIMS 25 INDEPENDENT CLAIMS 6
ADDRESS 38834				
TITLE Method for fabricating a semiconductor device including the use of a compound containing silicon and nitrogen to form an insulation film of SiN, SiCN or SiOCN <i>SiN or SiCN</i>				
FILING FEE RECEIVED 1448	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	